

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/566,116 Confirmation No. 3700  
Applicant : Akihisa Inoue et al.  
371 Filed : January 24, 2006  
Art Unit : 1793  
Examiner : Weiping Zhu  
Customer No. : 00270  
Title : SPUTTERING TARGET AND METHOD FOR PRODUCTION  
THEREOF

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

This is an Amendment submitted with a Request for Continued Examination (RCE) in timely response to a FINAL Office Action dated March 24, 2009. A Petition for a One Month Extension of Time to extend the deadline for response from June 24, 2009 to July 24, 2009, is being filed herewith. Kindly amend the application as set forth below.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.